

**RESPONSE UNDER 37 C.F.R. § 1.116
EXPEDITED PROCEDURE**

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

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|---|-----------------------------------|
| In re the Application of: | Confirmation No.: 5377 |
| Makiko KITAZOE, et al | Art Unit: 1792 |
| Application No.: 10/591,905 | Examiner: Keath T. CHEN |
| Filed: November 6, 2006 | Attorney Docket No.: 029567-00010 |
| For: SELF-CLEANING CATALYTIC CHEMICAL VAPOR DEPOSITION APPARATUS AND CLEANING METHOD THEREOF | |

AMENDMENT UNDER 37 C.F.R. §1.116

MAIL STOP AF

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

October 20, 2008

Sir:

In reply to the June 19, 2008, Office Action, the period for reply being extended by the attached Petition for Extension of Time, please amend the above-identified application as follows:

Amendments to the claims, as reflected in the listing of claims, being on page 2;
and

Remarks begin on page 7.